



Atty. Docket No.: 2846/2112 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

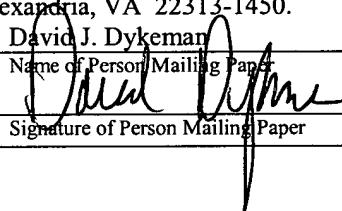
Application of:	Ren et al.	Examiner:	McNeil, Jennifer C.
Serial No.:	10/660,348	Group Art Unit:	1775
Filed:	September 11, 2003		
Entitled:	Metal Oxide Nanostructures with Hierarchical Morphology	Conf. No.:	5141

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8a

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**Commissioner for Patents
P.O. Box 1450
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AMENDMENT

Sir:

This Amendment is being filed in response to the Office Action mailed from the U.S. Patent and Trademark Office on April 1, 2005 in the above-identified application. Reconsideration and further examination are requested.

Amendments to the Claims are shown in the "Listing of the Claims" which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.

Please enter the following amendments and remarks.